



07/702492

- 1 -

Docket: 91-P205-USA-G

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Honorable Commissioner of Patents and Trademarks

Washington, D.C. 20231

Sir:

Transmitted herewith for filing is the patent application of:

Inventor(s): Takashi INUSHIMA
Shigenori HAYASHI
Toru TAKAYAMA
Masakazu ODAKA
Naoki HIROSE

For: CVD APPARATUS

Enclosed are:

[X] 8 sheets of drawings () formal (X) informal

[X] An assignment of the invention to:
Semiconductor Energy Laboratory Co., Ltd.

[X] Declaration and Power of Attorney.

[X] Priority is claimed based on foreign application(s)
No(s): 61-213323, 61-213324, 61-213325, 62-141050
Filed on: September 9, 1986, and June 5, 1987,
respectively. ✓

Filed in: Japan

Certified copy(s) [] attached; [XX] filed on
November 20, 1987, in prior U.S.S.N. 07/091,770,
filed September 1, 1987.

[] A verified statement to establish small entity status
under 37 CFR 1.9 and 37 CFR 1.27.

[X] Other: INFORMATION REGARDING INVENTORSHIP
Petition for Extension of Time in
parent application S.N. 07/497,794

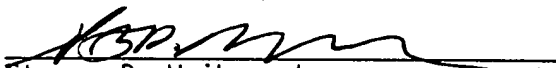
[X] The filing fee has been calculated as shown below.

<u>For:</u>	<u>No. Filed</u>	<u>No. Extra</u>	<u>Small/Large Entity Rate</u>	<u>Fee</u>
Basic Fee				\$315/630
Total Claims	<u>6</u> - 20 =	0	x 10/20	
Indep Claims	<u>1</u> - 3 =	0	x 30/60	
<u>Multiple Dependent Claim</u>			+ 100/200	
			TOTAL	<u>\$ 630</u>
[X] Assignment Recordation Fee				<u>\$ 8</u>
			TOTAL FEE	<u>\$ 638</u>

[X] A check in the amount of \$ 638.00 to cover the filing fee ~~to be enclosed~~ and assignment recording fee is enclosed.

[X] The Commissioner is hereby authorized to charge fees under 37 CFR 1.16 and 1.17 (except the Issue Fee) which may be required now or hereafter, or credit any overpayment, to Deposit Account No. 19-2380. A duplicate copy of this sheet is attached.

Respectfully submitted,


Steven P. Weihrouch
Reg. No. 32,829

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT application for)
Takashi INUSHIMA et al.)
Serial No.) Applications Branch
Filed: May 20, 1991)
For: CVD APPARATUS)

INFORMATION REGARDING INVENTORSHIP


Honorable Commissioner of Patents and Trademarks
Washington, D. C. 20231

Sir:

In preparation of the present Continuation-In-Part Application, an error in the names of the inventors of the parent application was discovered. In particular, "Inuzima" should have been --Inushima--, and "Seiichi" should have been --Masakazu--. The error was inadvertent and due to a translational mistake. The Declaration and Assignment documents attached to the present application reflect the corrected names. Since the parent application is to be abandoned, it is

believed that no further action is necessary on Applicants' part at this time. However, the above information is provided for completeness of the record and in compliance with Applicants' Duty of Candor.

Respectfully submitted,



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